

## **Microelectronics Innovation Collaborative Centre licenses Alchimer's wet deposition products for MEMS 3D research**

Medical Design Technology

Alchimer, a leading provider of nanometric deposition technology for through-silicon vias (TSVs), semiconductor interconnects, MEMS and other electronic applications, today announced that the Centre de Collaboration MiQro Innovation / MiQro Innovation Collaborative Centre (C2MI) has licensed its suite of products.

[SOURCE](#) [1]

[SOURCE](#) [2]

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[http://www.ecnmag.com/news/2011/03/microelectronics-innovation-collaborative-centre-licenses-alchimers-wet-deposition-products-mems-3d-research?qt-most\\_popular=0](http://www.ecnmag.com/news/2011/03/microelectronics-innovation-collaborative-centre-licenses-alchimers-wet-deposition-products-mems-3d-research?qt-most_popular=0)

**Links:**

[1] <http://www.i-micronews.com/lectureArticle.asp?id=6507>

[2] <http://www.MDTmag.com/News/Feeds/2011/03/products-electronic-components-microelectronics-innovation-collaborative-centre-l/>